

Inventor: Trung Tri Doan
Title: Variable Temperature Deposition Methods
Assignee: Micron Technology, Inc.
Docket No. MI22-1372



INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56.

Copies of documents listed on the Form PTO-1449 are enclosed.

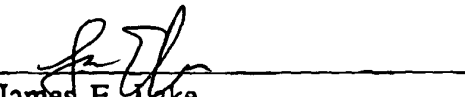
No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated: 8/8/01

Inventor: 
Trung Tri Doan

Dated: 09-Aug-2001

Attorney: 
James E. Lake
Reg. No.: 44,854

EL844048295

LIST OF ART CITED BY APPLICANT
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APPLICANT Trung Tri Doan

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Unassigned

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	5,270,247	12/1993	Sakuma et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AJ	EP 0 794 568	10/09/97	Europe	H01L	21/768	X	
	AK							
	AL							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AM	Noah Precision, Inc., Internet website: http://www.noahprecision.com/tec.htm ; "Thermoelectric Temperature Control" 1998, pps. 1-2.
	AN	Noah Precision, Inc., Internet website: http://www.noahprecision.com/cvd.htm ; "CVD" 1998, pps.1-2.
	AO	Kiyoko et al., Patent Abstract Application No. 04-024917 (JP 9224917, 09/1993), "Semiconductor Substrate and Its Manufacture."
	AP	Ritala, et al., "Atomic Layer Epitaxy - A Valuable Tool for Nanotechnology?" Nanotechnology, Vol. 10, No. 1, pps. 19-24, March 1999.
	AQ	George, et al., "Surface Chemistry for Atomic Layer Growth", Journal of Physical Chemistry, Vol. 100, No. 31, pps. 13121-13131, August 1, 1996.
	AR	Suntola, "Atomic Layer Epitaxy", Handbook of Crystal Growth, Vol. 3, Chapter 14, pps. 602-663, 1994.
	AS	Vernon, S.M., "Low-cost, high-efficiency solar cells utilizing GaAs-on-Si technology." Dialog Abstract of Report No. NREL/TP-451-5353; 04/1993.

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-1372		SERIAL NO. Unknown	
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U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	09/643,004		Mercaldi			08/21/2000
	AB	09/619,449		Derderian			07/19/2000
	AC	09/652,533		Derderian			08/31/2000
	AD						
	AE						
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	AH						
	AI						
	AJ						
	AK						
	AL						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AM						
	AN						
	AO						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AP						
	AQ						
	AR						
EXAMINER				DATE CONSIDERED			
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							

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